



AF/2814
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Attention: Mail Stop AF
Response Under 37 C.F.R. § 1.116
Expedited Procedure Requested
Examining Group 2814

PATENT
Customer No. 22,852
Attorney Docket No. 04329.2444-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Hiroshi TOYODA, et al.) Group Art Unit: 2814
Application No.: 10/600,568) Examiner: Weiss, Howard
Filed: June 23, 2003)
For: METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE)
INCLUDING TWO-STEP)
POLISHING OPERATION FOR CAP)
METAL)

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed June 18, 2004, with a period for response extending through September 20, 2004 (September 18, 2004 being a Saturday), Applicants propose amending the application as follows and request the Examiner's reconsideration in view of the remarks that follow:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 4 of this paper.